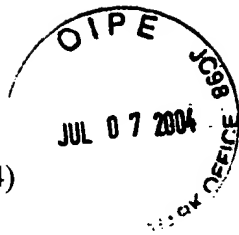


03500.015894 (35.C15894)



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | | |
|-------------------------------|---|---------------------------------|
| In re Application of: |) | |
| Takaharu KONDO, et al. |) | Examiner: Samuel A. Gebremariam |
| Application No.: 09/982,845 ✓ |) | Group Art Unit: 2811 |
| |) | |
| Filed: October 22, 2001 |) | |
| |) | |
| For: SILICON-BASED FILM AND |) | |
| PHOTOVOLTAIC ELEMENT |) | July 7, 2004 |

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATEMENT OF SUBSTANCE OF INTERVIEW

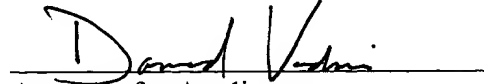
Sir:

Applicants wish to thank the Examiner for the courtesies extended to Applicants' undersigned representative during the telephonic interview conducted on May 28, 2004.

During the interview, Applicants' representative authorized the Examiner to incorporate the subject matter of Claim 9 into Claim 1.

Applicants' undersigned attorney may be reached in our Washington, D.C. office at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Damond E. Vadnais", is written over a horizontal line.

Attorney for Applicants
Damond E. Vadnais
Registration No. 52,310

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